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PATENT APPLICATION TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROSHI IZAWA ET AL.

Application No.: 09/837,459

Filed: April 19, 2001

For: DEPOSITED-FILM FORMATION
APPARATUS, DEPOSITED-FILM
FORMATION PROCESS, VACUUM
SYSTEM, LEAK JUDGMENT
METHOD, AND COMPUTER-
READABLE RECORDING MEDIUM;
WITH RECORDED LEAK-
JUDGMENT-EXECUTABLE
PROGRAM

Examiner: Not Yet Assigned

Group Art Unit: 2857

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JUN 05 2003
TC 1700
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JAN 17 2003
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August 12, 2002

OCT 28 2003

TC 1700

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AUG 28 2002

TC 1700

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The Examiner's attention is also directed to the following U.S. applications:

APPLICATION NO.FILING DATEGROUP ART UNIT

08/704,138

08/28/96

1763

09/469,797

12/22/99

1763

09/478,885

01/07/00

1763

09/867,493

05/31/01

1763

A copy of each cited application is enclosed.

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SEP 11 2003
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JAN 16 2004
TC 1700
JUN 24 2003
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It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 24017

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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